

Substitute for form 1449B/PTO <b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b>  Date Submitted: June 16, 2005 <i>(use as many sheets as necessary)</i>		<b>Complete if Known</b> <table border="1" style="width: 100%; border-collapse: collapse;"> <tr> <td style="width: 50%;">Application Number</td> <td style="width: 50%;">10/539290</td> </tr> <tr> <td>Filing Date</td> <td>06/16/2005</td> </tr> <tr> <td>First Named Inventor</td> <td>Kenji SATO</td> </tr> <tr> <td>Group Art Unit</td> <td>2872</td> </tr> <tr> <td>Examiner Name</td> <td>Arnel C. Lavarias</td> </tr> <tr> <td>Attorney Docket Number</td> <td>017525-0187</td> </tr> </table>		Application Number	10/539290	Filing Date	06/16/2005	First Named Inventor	Kenji SATO	Group Art Unit	2872	Examiner Name	Arnel C. Lavarias	Attorney Docket Number	017525-0187
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U.S. PATENT DOCUMENTS						
Examiner Initials*	Cite No. <sup>1</sup>	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number	Kind Code <sup>2</sup> (if known)			
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		Office <sup>3</sup>	Number <sup>4</sup>	Kind Code <sup>5</sup> (if known)				
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NON PATENT LITERATURE DOCUMENTS			
Examiner Initials*	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.) date, page(s), volume-issue number(s), publisher, city and/or country where published.	T <sup>6</sup>
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Examiner Signature	/Arnel C. Lavarias/	Date Considered	05/05/2008
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